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28158

Attorney Docket SEL 195

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
)  
Yamazaki et al. )  
)  
Serial No.: 09/610,753 )  
)  
Filed: July 6, 2000 )  
)  
For: Semiconductor Device And )  
Manufacturing Method Thereof )  
)  
Art Unit: 2815 )  
)  
Examiner: P. Brock III )

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Shannon Wallace

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Signature

Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT F**

Sir:

In response to the Office Action of January 20, 2004, a two month extension of time being submitted herewith, please amend the above-identified application as follows: